



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

: **Confirmation No. 6339**

Kazufumi SATO et al.

: Docket No. 2003\_1687

Serial No. 10/716,632

: Group Art Unit 1752

Filed November 20, 2003

: Examiner Yvette C. Thornton

POSITIVE-WORKING PHOTORESIST  
COMPOSITION

**Mail Stop: Amendment**

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**RESPONSE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated June 29, 2005, please amend the present application as follows: